

<b>INFORMATION DISCLOSURE CITATION</b>	<b>Docket No.: 0094.072</b>	<b>Serial No.:</b>
	<b>Inventor: James V. Crivello</b>	<b>Examiner:</b>
	<b>Filing Date:</b>	<b>GAU:</b>

#### UNITED STATES PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Subcl ass	Filing Date If Appropriate
	AA	3,457,193	07/22/69	Tinsley et al.	260	2	June 30, 1065
	AB	3,415,794	10/10/68	Orth et al.	260	78.5	March 28, 1966
	AC	5,463,084	11/31/95	Crivello et al.	549	214	February 1, 1993

#### FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Int'l Clas s	Int'l Subclass	Translation	
							Yes	No

#### OTHER DOCUMENTS

(Including Author, Title, Date Pertinent Pages, Etc.)

	CA	H.Sasaki and J.V.Crivello, "The Synthesis, Characterization, and Photoinitiated Cationic Polymerization of Difunctional Oxetanes", <i>Journal of Macromolecular Science-Pure Appl. Chem.</i> A29(10), 915-930 (1992).
	CB	J.V. Crivello and H. Sasaki, "Synthesis and Photopolymerization of Silicon-Containing Multifunctional Oxetane Monomers", <i>Journal of Macromolecular Science-Pure Appl. Chem.</i> A30 (2&3) 173-187 (1993).
	CC	J.V. Crivello and H. Sasaki, "Structure and Reactivity Relationships in the Photoinitiated Cationic Polymerization of Oxetane Monomers", <i>Journal of Macromolecular Science-Pure Appl. Chem.</i> A30 (2&3) 189-206 (1993).
	CD	B. Falk et. al., "Monitoring Photopolymerization Reactions with Optical Pyrometry", <i>Journal of Polymer Science: Part A: Polymer Chemistry</i> , 41, 579-596 (2003).
	CE	C. Decker et. al., "Light Intensity and Temperature Effect in Photoinitiated Polymerization", <i>ACS Symp. Ser.</i> 673, 63 (1997).
	CF	Hiroshi Sasaki Toagosei Co. Ltd., "Oxetanes: Curing Properties in Photo-Cationic Polymerization", <i>RadTech Technical Proceedings</i> , 61-68 (2000)

	CG	Bidali et. al., "Heat and UV – Ignited Frontal Polymerization of an Epoxy Resin", Poster from Presentation from Ischia, Italy, June 2003.
EXAMINER:		Date Considered
<b>EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</b>		